

## Elefant Dieter

52 cuvinte-cheie

Distribuirea publicațiilor pe cuvinte-cheie și ani

Nr.	Cuvinte-cheie	Total pe autor	Total în IBN	2008	2007
1	<a href="#">A2 phase</a>	1	1	-	1
2	<a href="#">Alternating gradient magnetometry (AGM)</a>	1	1	-	1
3	<a href="#">Anisotropic magnetoresistances</a>	1	1	1	-
4	<a href="#">B2 phase</a>	1	1	-	1
5	<a href="#">Beam evaporations</a>	1	1	1	-
6	<a href="#">Brillouin light scattering (BLS)</a>	1	1	-	1
7	<a href="#">Bulk samples</a>	1	3	-	1
8	<a href="#">Co<sub>2</sub> Cr<sub>x</sub> Fe<sub>1-x</sub> Al (CFFA)</a>	1	1	-	1
9	<a href="#">Engineering controlled terms Electric resistance</a>	1	2	1	-
10	<a href="#">Epitaxial growth</a>	1	10	1	-
11	<a href="#">Epitaxially grown</a>	1	1	1	-
12	<a href="#">Field strengths</a>	1	1	1	-
13	<a href="#">Form anisotropy</a>	1	1	-	1
14	<a href="#">Full-Heusler</a>	1	1	-	1
15	<a href="#">g-Factor</a>	1	2	-	1
16	<a href="#">GaAs substrates</a>	1	2	1	-
17	<a href="#">Gallium alloys</a>	1	12	1	-
18	<a href="#">Gyromagnetic factor</a>	1	1	-	1
19	<a href="#">Heusler-alloy</a>	1	1	-	1
20	<a href="#">High magnetic fields</a>	1	5	1	-
21	<a href="#">hysteresis</a>	1	18	-	1
22	<a href="#">L 21 phase</a>	1	1	-	1
23	<a href="#">Linewidth</a>	1	4	-	1
24	<a href="#">Low magnetic fields</a>	1	1	1	-
25	<a href="#">Magnetic field effects</a>	1	20	1	-
26	<a href="#">Magnetic field measurement</a>	1	1	1	-
27	<a href="#">Magnetic fields</a>	1	50	1	-
28	<a href="#">Magnetic materials</a>	1	13	1	-
29	<a href="#">Magnetic moment</a>	1	4	-	1
30	<a href="#">Magnetic moments</a>	1	15	1	-
31	<a href="#">magnetic properties</a>	2	84	1	1
32	<a href="#">magnetism</a>	1	91	1	-
33	<a href="#">Magnetization measurements</a>	1	1	1	-
34	<a href="#">Magneto-optic Kerr effect (MOKE)</a>	1	1	-	1
35	<a href="#">Magnetoelectronics</a>	1	3	1	-
36	<a href="#">Magnetoresistance</a>	1	44	1	-
37	<a href="#">Magnets</a>	1	16	1	-
38	<a href="#">Magnon scatterings</a>	1	1	1	-

<b>Nr.</b>	<b>Cuvinte-cheie</b>	<b>Total pe autor</b>	<b>Total în IBN</b>	<b>2008</b>	<b>2007</b>
39	<a href="#">Metallic materials</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
40	<a href="#">Molecular beam epitaxy</a>	<u>1</u>	<u>11</u>	<u>1</u>	-
41	<a href="#">saturation magnetization</a>	<u>1</u>	<u>7</u>	-	<u>1</u>
42	<a href="#">Semiconducting silicon compounds</a>	<u>1</u>	<u>4</u>	<u>1</u>	-
43	<a href="#">Si films</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
44	<a href="#">Silicon</a>	<u>1</u>	<u>31</u>	<u>1</u>	-
45	<a href="#">Strontium compounds</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
46	<a href="#">Temperature resistivities</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
47	<a href="#">Transport and magnetic properties</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
48	<a href="#">Transverse magnetoresistances</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
49	<a href="#">Ultrahigh vacuum chambers Engineering main heading Epitaxial films</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
50	<a href="#">vacuum</a>	<u>1</u>	<u>14</u>	<u>1</u>	-
51	<a href="#">Vacuum evaporation Engineering uncontrolled terms Absolute values</a>	<u>1</u>	<u>1</u>	<u>1</u>	-
52	<a href="#">X-ray diffraction (XRD)</a>	<u>1</u>	<u>1</u>	-	<u>1</u>
	<b>Total</b>	<b>53</b>	<b>493</b>	<b>34</b>	<b>19</b>